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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/734,072
Confirmation No. 8908
Filing Date December 10, 2003
Inventor Mark E. Tuttle et al.
Assignee Micron Technology, Inc.
Group Art Unit 2891
Examiner Caridad Everhart
Customer No. 021567
Attorney Docket No. MI40-369
Title: Methods for Forming Integrated Circuits Within Substrates

RESPONSE TO FEBRUARY 9, 2006 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS

Responsive to the Office Action dated February 9, 2006 in this Reissue application, Applicants amend and remark as follows. Unless otherwise indicated, deletions are bracketed, additions are underlined.